Search Notes			

Application/Control No.	Applicant(s)/Patent under Reexamination
09/902,261	OGISHI ET AL.
Examiner	Art Unit
Chau Nguven	2176

	SEARCHED				
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Class	Subclass	Date	Examiner		
715	513	8/25/2004	CN		
715	516	8/25/2004	CN		
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	DATE	EXMR
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